

Voltage-Controlled and Input-Matched Tunable Microstrip Attenuators Based on Few-Layer Graphene

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# Voltage-Controlled and Input-Matched Tunable Microstrip Attenuators Based on Few-Layer Graphene

Muhammad Yasir, *Student member, IEEE*, Silvia Bistarelli, Antonino Cataldo, Maurizio Bozzi, *Fellow, IEEE*, Luca Perregrini, *Fellow, IEEE*, and Stefano Bellucci

**Abstract**—This paper presents novel tunable microstrip attenuators based on few-layer graphene. The proposed topology consists of a microstrip line sided by pairs of grounded metal vias, with graphene pads located between the microstrip line and the vias. The possibility to control the graphene resistance through an applied bias voltage is exploited with the aim to modify the insertion loss of the attenuators. Several pairs of metal vias are adopted to achieve large tuning range, good input matching, and broadband operation. A systematic investigation of the structure with two, three, and four pairs of vias is presented, along with experimental validation. Prototypes operating in the frequency range from 1 GHz to 10 GHz and with maximum insertion loss exceeding 60 dB are fabricated and tested.

**Index Terms**— Graphene, microstrip lines, tunable microwave devices, voltage-controlled attenuator.

## I. INTRODUCTION

THE INTERESTING ELECTRONIC PROPERTIES of graphene have got significant attention in the recent years, due to the extraordinary electrical and mechanical features [1]-[3]. In the microwave frequency range, graphene exhibits the property of changing its resistance upon the application of an electric field [4]-[13]. Along with other materials (e.g., [14], [15]), the graphene represents an excellent candidate for developing microwave tunable devices. In particular, the voltage-controlled change in resistance was exploited to develop microstrip attenuators [6]-[7]. The change in graphene resistance on the application of a gate voltage was also experimentally demonstrated [8]. Moreover, the graphene tunable resistance was applied to the development of absorbers [9]-[10], phase shifters [11], and antennas [12]-[13].

Depending on the technological fabrication process, graphene for microwave applications can be realized in the form of a single layer or multiple layers [16]-[18]. Single layer graphene is technologically demanding, but on the other hand the tunable resistance characteristics of graphene are also

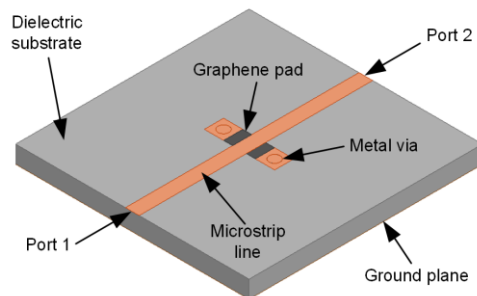


Fig. 1. Geometry of the graphene-based tunable microstrip attenuator proposed in [7].

present in multilayer graphene, up to ten-layer configuration [2]. This latter property makes multilayer graphene a very good contender for use in cheap electronic and microwave circuits and systems. A cost effective and very fast method to obtain multilayer graphene was proposed in [6], [18]. This is a two-step process, which involves the microwave irradiation of intercalated graphite and a subsequent ultrasound treatment in isopropyl alcohol.

In this paper, the tunability of graphene resistance at microwave frequency and the low-cost fabrication process of multilayer graphene are combined to implement a novel class of voltage-controlled and input-matched tunable microstrip attenuators. A first implementation of a tunable microstrip attenuator based on multilayer graphene was presented in [6]. The attenuator comprised of a microstrip line with a gap, where the graphene was deposited, thus resulting in a line with a series variable resistor. A change in the graphene resistance was used to vary the attenuation of the signal between the two ports, achieving an insertion loss ranging from 5.5 dB to 10 dB at the frequency of 10 GHz. Subsequently, an improved version of graphene attenuator was developed [7]. This structure consisted of a microstrip line with two grounded vias, and the graphene was deposited in the gaps between the grounded vias and the microstrip line, as shown in Fig. 1. This structure behaves as a line with two shunt resistors, and increasing their conductivity leads to diverting the signal to ground, thus increasing the insertion loss. The achieved insertion loss ranged from 0.3 dB to 15 dB at the frequency of 3 GHz, but a large portion of the attenuation was due to reflection loss.

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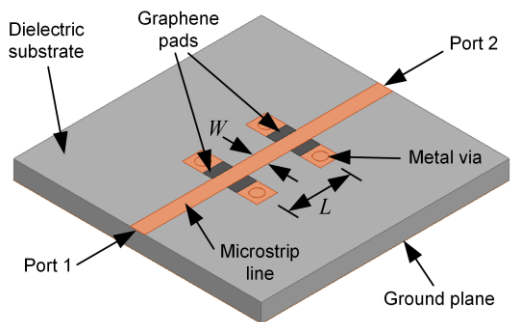


Fig. 2. Geometry of the two-pair posts tunable attenuator.

The use of multiple pairs of grounded vias with graphene in the gaps between the vias and the microstrip line allows to solve the problem of the input mismatch, along with the possibility to extend the tuning range of the insertion loss and to broaden the operation frequency band. Preliminary and partial results of this study were presented in conference papers [19], [20].

In this work, a thorough investigation of the performance of graphene attenuators is presented. The use of multiple pairs of grounded vias with graphene in the gaps between the vias and the microstrip line is considered, and a systematic parametric study is presented. The possibility to achieve large tuning range and good input matching is investigated in detail. Experimental validation is proposed for optimized configurations, in the case of two, three, and four pairs of metal vias.

## II. CONDUCTION MECHANISM IN FEW LAYER GRAPHENE REGIONS

For a theoretical description of the conduction mechanism in the graphene nanoplatelets region in posts of the attenuator, the random *RCD* network model can be used [21], [22]. This model is based on a ternary network in which the basic elements depend on the composition and geometry of the regions. The first element, i.e. the resistor  $R$ , derives from conducting regions where agglomerates of nanocarbon are present. The second element is a capacitor  $C$ , coming from dielectric regions where the dielectric material is the air between graphene flakes. The third and last element is a diode  $D$ , arising from hopping regions where well-dispersed nanographene particles generate hopping conductivity. These regions are randomly dispersed in graphene pads.

For a complete understanding of the process, it is possible to imagine different filling steps of the gap with increasing density of the drop casted graphene nanoplatelets, as the solvent (isopropyl alcohol) progressively evaporates, thus forming the deposit in the gap. At the beginning of the graphene nanoplatelets deposition process, only regions disconnected from each other are present. However, as the solvent's evaporations proceeds, an increasing number of previously distinct regions will approach each other until, in the end of the evaporation, a conductive network is created. The deposit in the gap is so constituted by a network of

nanostructures, i.e. the graphene nanoplatelets, each of them being several micrometers wide (see Fig. 1(a) in [23]), and having a crystalline structure made of stacks of 4-10 atomic layers of graphene (see Fig. 1(b) in [23]). The contact between the different regions is electrostatic, which is why the applicable bias between the graphene pads has a maximum value above which the circuit physically breaks [6].

In the *RCD* model, this break is associated with a disconnection of the conductive network. The graphene nanoplatelets are electrically connected by electrostatic interactions ( $\pi$ - $\pi$ ). Hence, by changing the resistivity of the graphene region, it may happen that the relative positions of the overlapping layer would be not spatially permanent. This may explain the appearing of a breakdown voltage in earlier devices, e.g. [6].

An interesting development might rely in the onset or presence of graphene-oxide. Indeed, it could happen that the graphene nanoplatelets sample could be contaminated by the graphene oxide, which in turn could enhance the oxygen-atom corrosion resistance, thus changing the conductivity response. There are important papers on the issue (e.g., [24]). On the other hand, the presence of oxidated graphene in the samples we use has been excluded by earlier characterizations [25].

## III. TWO-PAIR POSTS ATTENUATOR

The two-pair posts attenuator is composed of two couples of grounded vias, located at the sides of the microstrip line, as shown in the Fig. 2.

All attenuators presented in this work were implemented on a Taconic RF-60 substrate, with thickness  $h=0.64$  mm, relative dielectric permittivity  $\epsilon_r=6.15$ , and loss tangent  $\tan\delta=0.0028$ . The width of the input/output microstrip lines was set at 0.94 mm, in order to have a characteristic impedance of 50  $\Omega$ . Where not otherwise stated, the grounded vias have a diameter of 1.00 mm, the top metal patch is a square with side length of 1.40 mm, and the graphene pad is a rectangle with dimensions 1.40 mm by 0.66 mm. These dimensions were obtained along the lines of [7]. The commercial FEM software Ansys HFSS was adopted to perform simulations and parametric analyses of the proposed structures. Graphene was modelled as an infinitely thin resistive sheet, as discussed in [7].

In the case of two pairs of graphene pads, the distance  $L$  between the two pairs and the width  $W$  of the central microstrip section affect the insertion loss and operation bandwidth. For this reason, three different values for the distance  $L$  were analyzed in Fig. 3. Since the frequency band of operation ranges from 1 GHz to 10 GHz, the values of length  $L$  were chosen as 5 mm, 10 mm, and 15 mm, which correspond to approximately  $\lambda/6$ ,  $\lambda/3$ , and  $\lambda/2$ , respectively, at the center frequency of 5 GHz. In order to observe the impact of the distance  $L$  on the attenuator performance, different values of graphene resistance were considered in the simulation, all falling in the range of the actual graphene resistance. It is observed in Fig. 3 that decreasing the graphene resistance leads to a larger insertion loss, ranging from 1.5 dB to more than 30 dB. Conversely, the input matching tends to degrade when decreasing the graphene resistance. Moreover, the shortest distance  $L=5$  mm provides a flatter and quasi ripple-free transmission over the entire frequency band.

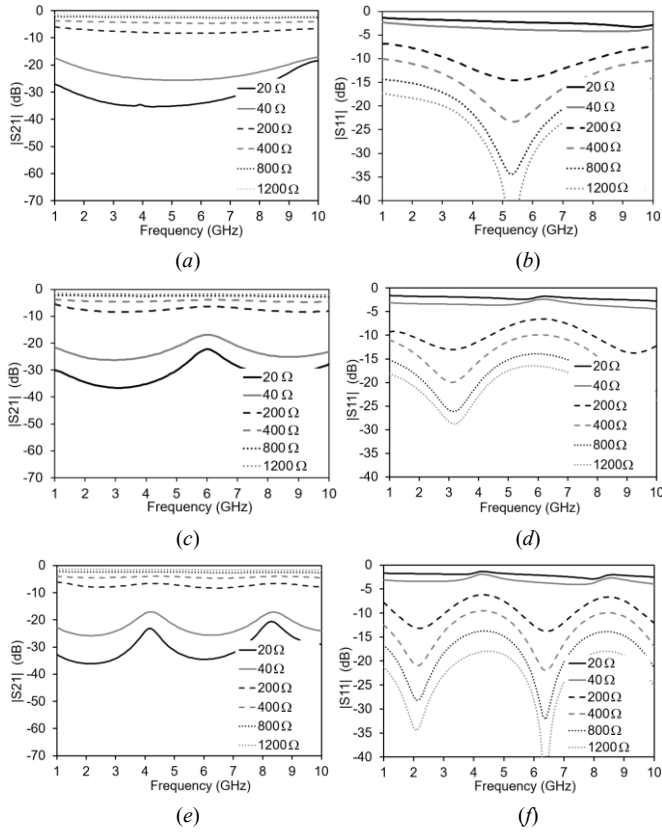


Fig. 3. Parametric simulations of the two-pair posts attenuator with variation of the midline length  $L$  (with  $W=940 \mu\text{m}$ ): (a)  $|S_{21}|$  with  $L=5 \text{ mm}$ ; (b)  $|S_{11}|$  with  $L=5 \text{ mm}$ ; (c)  $|S_{21}|$  with  $L=10 \text{ mm}$ ; (d)  $|S_{11}|$  with  $L=10 \text{ mm}$ ; (e)  $|S_{21}|$  with  $L=15 \text{ mm}$ ; (f)  $|S_{11}|$  with  $L=15 \text{ mm}$ .

The other considered optimization parameter was the width  $W$  of the central microstrip section. The outer parts of the transmission line could not be different from  $50 \Omega$  to ensure matched connection to the ports. Three different values of width  $W$  equal to  $940 \mu\text{m}$ ,  $630 \mu\text{m}$ , and  $470 \mu\text{m}$  were analyzed, corresponding to characteristic impedance of  $50 \Omega$ ,  $75 \Omega$ , and  $100 \Omega$ , respectively. The scattering parameters for all cases are shown in Fig. 4. The thickness of the central microstrip line has a minimal impact on the performance of the attenuator, the only effect being a slight increase in the insertion loss when  $W$  becomes smaller (while keeping the dynamic range constant), along with a minor degradation of the input matching. Since it is desirable to minimize the minimum insertion loss and to maximize the input matching, the optimum value is  $W=940 \mu\text{m}$  ( $50\text{-}\Omega$  line).

Based on the results of the parametric analysis, a prototype of the two-pair posts attenuator was fabricated with the optimized values  $L=5 \text{ mm}$  and  $W=940 \mu\text{m}$ .

The planar circuitry was realized by using an LPKF milling machine, and the vias were metalized by conductive paste. Graphene flakes were subsequently deposited as discussed in [6]. A photograph of the prototype is shown in Fig. 5(a), together with the measurement setup.

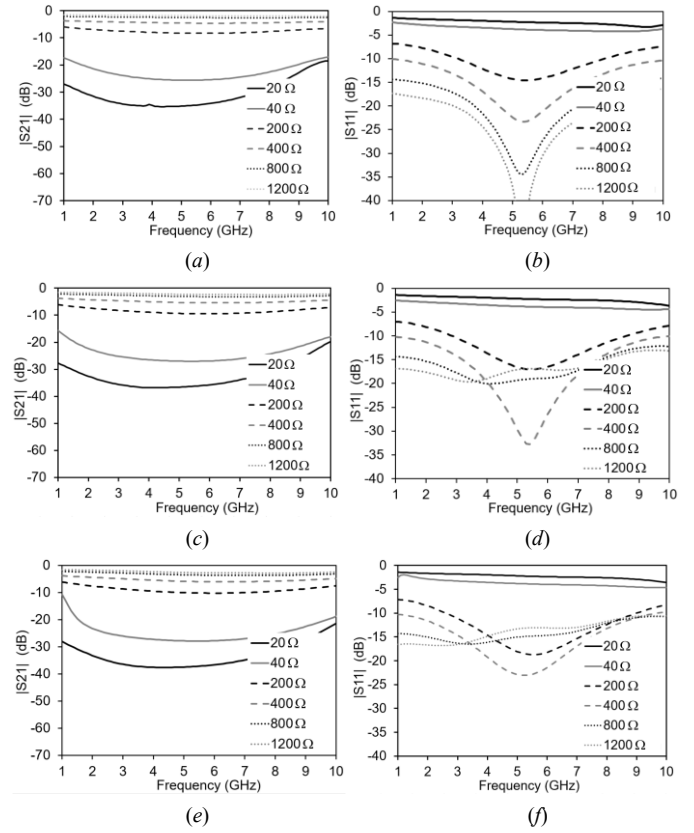


Fig. 4. Parametric simulations of the two-pair posts attenuator with variation of the midline width  $W$  (with  $L=5 \text{ mm}$ ): (a)  $|S_{21}|$  with  $W=940 \mu\text{m}$  ( $50 \Omega$ ); (b)  $|S_{11}|$  with  $W=940 \mu\text{m}$ ; (c)  $|S_{21}|$  with  $W=630 \mu\text{m}$  ( $75 \Omega$ ); (d)  $|S_{11}|$  with  $W=630 \mu\text{m}$ ; (e)  $|S_{21}|$  with  $W=470 \mu\text{m}$  ( $100 \Omega$ ); (f)  $|S_{11}|$  with  $W=470 \mu\text{m}$ .

The graphene resistance was preliminarily measured, by applying the desired bias voltage and measuring the corresponding DC current. The measured DC current is equally divided into the four grounded vias, which are in parallel at DC. Table I shows the applied bias voltage  $V_{\text{bias}}$ , the DC current  $I_{\text{dc}}$  flowing across each graphene pad, and the resulting equivalent resistance  $R=V_{\text{bias}}/I_{\text{dc}}$  of the single graphene pad. As expected, the resistance  $R$  decreases when increasing the applied bias voltage.

RF measurements were carried out with a vector network analyzer, and the graphene was biased by using a bias-tee [Fig. 5(a)]. The variation of the graphene resistance versus the bias voltage allows controlling the insertion loss of the

TABLE I—GRAPHENE RESISTANCE OF THE TWO-PAIR POSTS ATTENUATOR

$V_{\text{bias}}$ (V)	$I_{\text{dc}}$ (A)	$R$ ( $\Omega$ )
0	$\infty$	1550*
3.5	0.0085	410
4	0.016	250
5.5	0.119	46

\* Measured by using a multimeter.

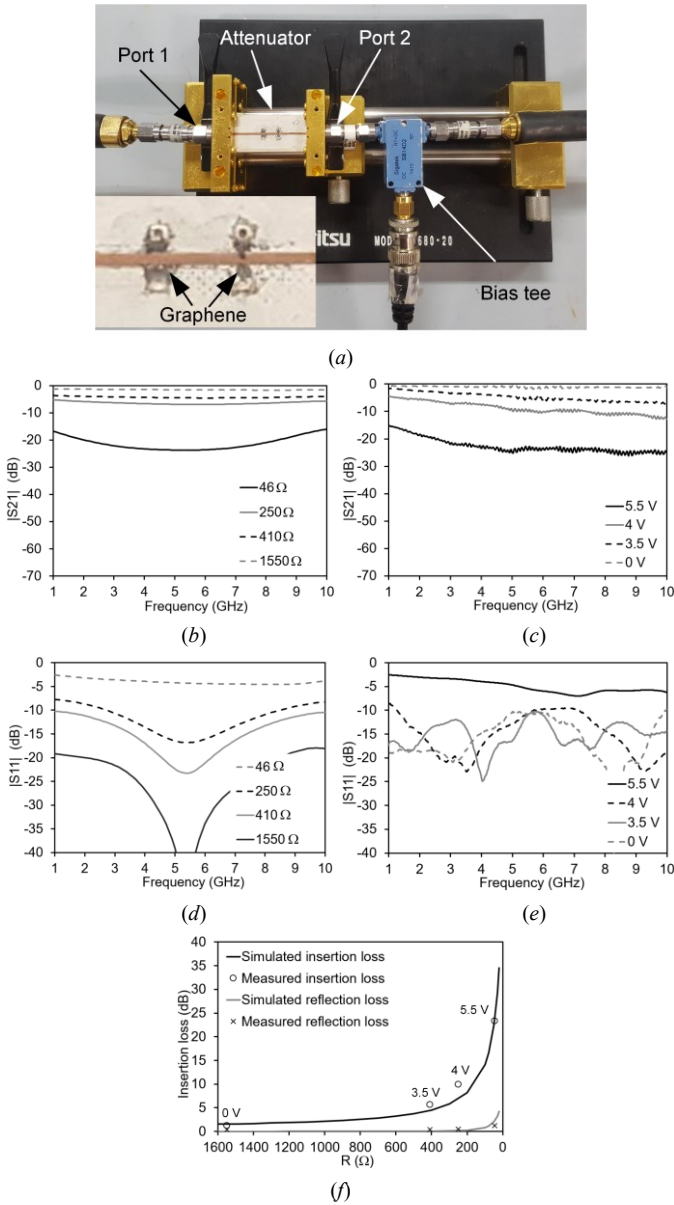


Fig. 5. Experimental verification of the two-pair posts graphene attenuator: (a) Photograph of the prototype; (b) Simulated transmission; (c) Measured transmission; (d) Simulated reflection; (e) Measured reflection; (f) Simulated and measured insertion loss at 6 GHz.

attenuator. When increasing the DC bias voltage, the resistance of graphene reduces, thus increasing the insertion loss. Figs. 5(b)-5(e) show the scattering parameters of the attenuator obtained from measurements (with different values of bias voltage  $V_{\text{bias}}$ ) and from simulations (performed with the corresponding values of graphene resistance  $R$ , see Table I). In the frequency range from 3 GHz to 10 GHz, the measured insertion loss ranges from a low value of  $1.2 \pm 0.6$  dB at zero bias voltage to a high value of  $24 \pm 2$  dB at a bias voltage of 5.5 V.

A clear summary of the attenuator performance at the central frequency of 6 GHz is provided in Fig. 5(f), which shows the simulated and measured total insertion loss as well as the portion of insertion loss due to reflection. The total

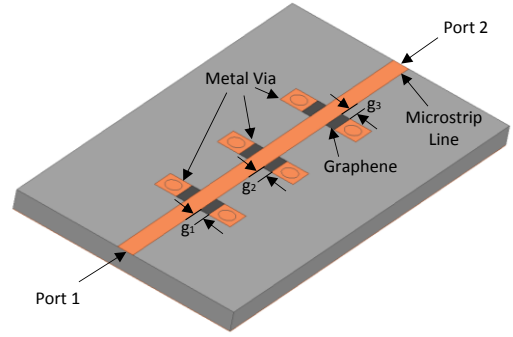


Fig. 6. Geometry of the three-pair posts tunable attenuator.

insertion loss at 6 GHz ranges from 1.2 dB at  $V_{\text{bias}}=0$  to 24 dB at  $V_{\text{bias}}=5.5$  V. The reflection loss does not exceed the value of 4 dB at  $V_{\text{bias}}=5.5$  V. The maximum value of bias voltage is determined by the breakdown of the device [6].

#### IV. THREE-PAIR POSTS ATTENUATOR

An increased number of pairs of graphene pads with grounded vias was adopted to achieve a higher insertion loss and to improve the input matching. In the second structure, the number of pairs was increased to three (Fig. 6).

As a baseline, all design parameters were kept identical to the attenuator with two pairs of posts, discussed in the previous section. In this section, the effect of the dimensions of the graphene pads  $g_1$ ,  $g_2$ , and  $g_3$  on the transmission scattering parameters is analyzed. For sake of symmetry, the dimension of the outer graphene pads is kept identical, with  $g_1=g_3$ .

In the first parametric study, the dimension  $g_2$  of the inner graphene pad was varied (Fig. 7), considering the nominal value ( $g_2=660 \mu\text{m}$ ) and reductions to 70% ( $g_2=462 \mu\text{m}$ ) and to 40% ( $g_2=264 \mu\text{m}$ ). As shown in Fig. 7, the decrease in  $g_2$  results in an increase of the insertion loss, both in the maximum value (desirable) and in the minimum value (highly undesired). Moreover, decreasing  $g_2$  has a detrimental effect on the input matching.

In the second parametric study, the same variation was applied to the dimensions  $g_1=g_3$  of the outer graphene pads. The results in terms of the scattering parameters are as shown in the Fig. 8. The impact of the outer pads size reduction is similar to the inner one, resulting into an increase of both minimum and maximum insertion loss and a degradation of the input matching. In this case, the performance degradation is even more pronounced, as it involves two pairs of graphene pads (the outer ones) instead of one (the inner one).

Based on the parametric analyses, the dimensions  $g_1=g_2=g_3=660 \mu\text{m}$  was adopted for the final prototype. The prototype of the attenuator with three pairs of graphene pads was fabricated, and its picture is shown in Fig. 9(a).

The measurement setup adopted for the DC and RF measurements is identical to the one described in Sec. II and shown in Fig. 5(a).

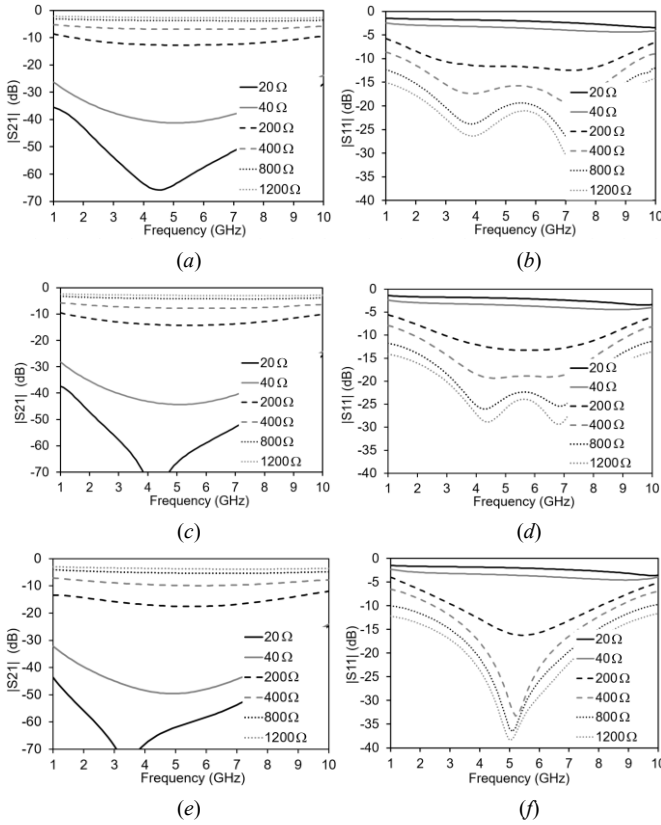


Fig. 7. Parametric simulations of the three-pair posts attenuator with variation of the inner graphene pad dimension  $g_2$ , with  $g_1=g_3=660 \mu\text{m}$ : (a)  $|S_{21}|$  with  $g_2=660 \mu\text{m}$ ; (b)  $|S_{11}|$  with  $g_2=660 \mu\text{m}$ ; (c)  $|S_{21}|$  with  $g_2=462 \mu\text{m}$ ; (d)  $|S_{11}|$  with  $g_2=462 \mu\text{m}$ ; (e)  $|S_{21}|$  with  $g_2=264 \mu\text{m}$ ; (f)  $|S_{11}|$  with  $g_2=264 \mu\text{m}$ .

As a first step, the graphene resistance was measured, for different values of bias voltage. Table II shows the applied bias voltage  $V_{\text{bias}}$ , the measured DC current  $I_{\text{dc}}$  flowing across each graphene pad, and the equivalent resistance  $R$  of the single graphene pad.

Subsequently, RF measurements were performed, and the comparison between simulations and measurements of the scattering parameters are shown in Figs. 9(b)-9(e). Also in this case, the resistance values adopted in the simulations correspond to the applied bias voltage used in the measurements, according to the results of Table II. In the frequency range from 3 GHz to 10 GHz, the measured insertion loss ranges from a low value of  $1.7 \pm 0.9$  dB at zero bias voltage to a high value of  $32 \pm 4$  dB at a bias voltage of 6 V.

A summary of the attenuator performance at the central frequency of 6 GHz is provided in Fig. 9(f), which shows the simulated and measured total insertion loss as well as the portion of insertion loss due to reflection. The structure with three pairs of graphene pads provides a larger value of maximum insertion loss, while preserving low minimum insertion loss and good input matching. In particular, at the central frequency of 6 GHz, the maximum measured insertion loss in this case is around 33 dB with a bias voltage of 6 V, the minimum insertion loss is 1.2 dB for 0 V, and the reflection loss does not exceed the value of 1.1 dB at 6 V.

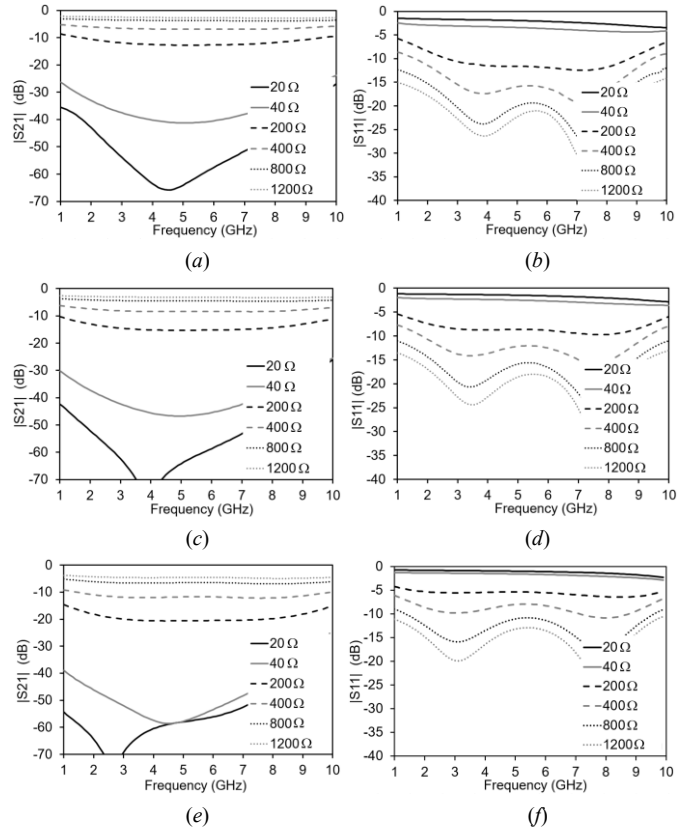


Fig. 8. Parametric simulations of the three-pair posts attenuator with variation of the outer graphene pad dimensions  $g_1=g_3$ , with  $g_2=660 \mu\text{m}$ : (a)  $|S_{21}|$  with  $g_1=g_3=660 \mu\text{m}$ ; (b)  $|S_{11}|$  with  $g_1=g_3=660 \mu\text{m}$ ; (c)  $|S_{21}|$  with  $g_1=g_3=462 \mu\text{m}$ ; (d)  $|S_{11}|$  with  $g_1=g_3=462 \mu\text{m}$ ; (e)  $|S_{21}|$  with  $g_1=g_3=264 \mu\text{m}$ ; (f)  $|S_{11}|$  with  $g_1=g_3=264 \mu\text{m}$ .

## V. FOUR-PAIR POSTS ATTENUATOR

An attenuator based on four pairs of graphene pads and grounded vias was designed and fabricated, based on the parametric analyses presented in the previous sections. The aim of this last structure is to achieve maximum range of insertion loss with minimum degradation of the input matching, over the frequency band from 1 GHz to 10 GHz.

The proposed design of four-pairs post attenuator is as shown in the Fig. 10, where the dimensions coincide with the optimal values derived from the parametric analyses ( $L=5$  mm,  $W=0.94$  mm,  $s=1.40$  mm, and  $g=0.66$  mm). A photograph of the prototype is shown in the Fig. 11(a).

TABLE II – GRAPHENE RESISTANCE VERSUS VOLTAGE FOR THE THREE-PAIR POSTS ATTENUATOR

$V_{\text{bias}}$ (V)	$I_{\text{dc}}$ (A)	$R$ ( $\Omega$ )
0	—	1443*
2	0.0021	950
4	0.0139	286
6	0.1052	57

\* Measured by using a multimeter.

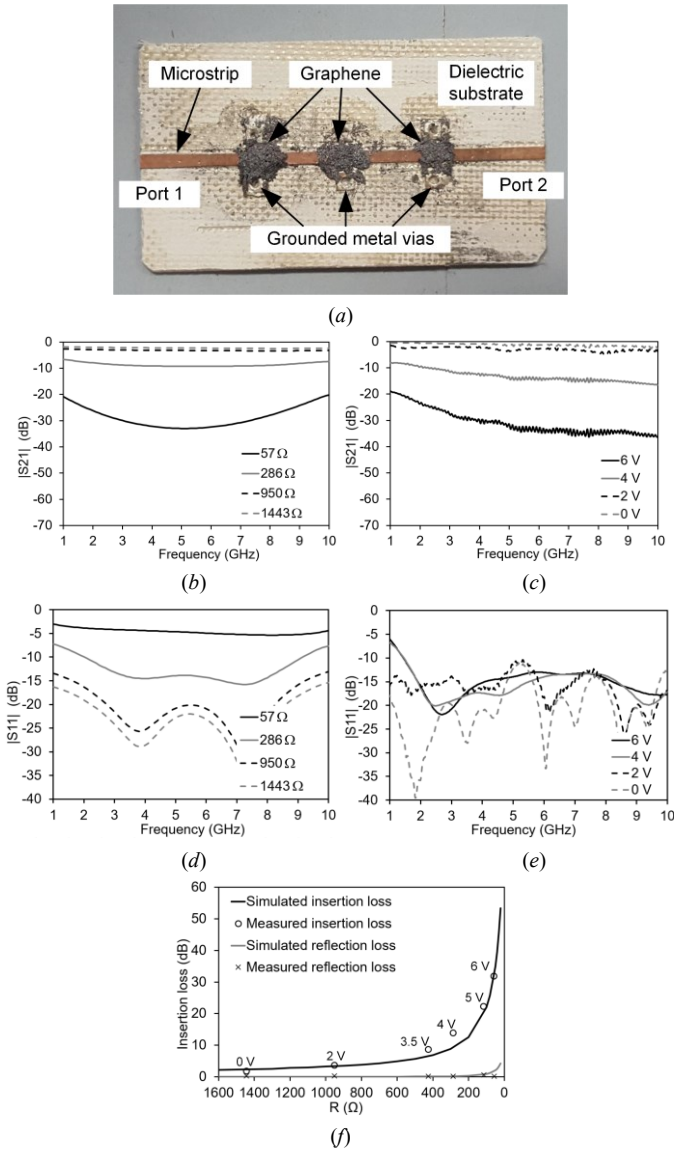


Fig. 9. Experimental verification of the three-pair posts graphene attenuator: (a) Photograph of the prototype; (b) Simulated transmission; (c) Measured transmission; (d) Simulated reflection; (e) Measured reflection; (f) Simulated and measured insertion loss at 6 GHz.

Measurements of the prototype were performed as in the other two cases. Preliminary DC measurements allow to obtain the graphene resistance as a function of the applied bias voltage, as shown in Table III. The comparison of simulations and RF measurements is provided in Figs. 11(b)-11(e), where the simulated scattering parameters obtained with different values of graphene resistance are compared with measured results achieved with the corresponding values of bias voltage (Table III). The use of four pairs of graphene pads allows to achieve a very large dynamic range of the insertion loss. The measured insertion loss is larger than 48 dB in the frequency band from 3 GHz to 10 GHz with a bias voltage of 7 V, and the minimum insertion loss (at zero bias voltage) ranges from 1.2 dB at 3 GHz to 3.9 dB at 10 GHz. The input matching is better than 5 dB in the same frequency band.

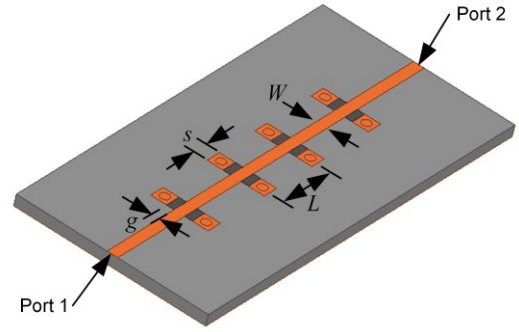


Fig. 10. Geometry of the four-pair posts tunable attenuator.

The simulated and measured total insertion loss and the portion of insertion loss due to reflection are shown in Fig. 11(f). At the frequency of 6 GHz, the attenuation loss is 59 dB where the insertion loss due to reflection does not exceed the value of 2.3 dB.

## VI. DISCUSSION AND COMPARISON WITH STATE-OF-THE-ART

The comparison of the different solutions proposed in this paper shows that increasing the number of pairs of graphene pads allows to extend the dynamic range of the insertion loss and to reduce the reflection loss.

The basic principle of operation of the proposed tunable attenuator can be easily understood by adopting the equivalent circuit model shown in Fig. 12(a), where each pair of graphene pads, connected to ground by shorting vias, is represented by a resistor connected to ground. Fig. 12 also shows the circuit-based simulation results for different cases: more specifically, it reports the scattering parameters of the attenuators with one pair [Figs. 12(b) and 12(c)], two pairs [Figs. 12(d) and 12(e)], three pairs [Figs. 12(f) and 12(g)], and four pairs [Figs. 12(h) and 12(i)] of graphene pads, for different values of graphene resistance. The results shown in Fig. 12 demonstrate that, by increasing the number of pairs of graphene pads, there are additional degrees of freedom in the structure and this allows to increase significantly both the bandwidth of the input matching and the dynamic range of the insertion loss.

Finally, to better appreciate this behavior, Fig. 13 shows the total insertion loss and the reflection loss versus the bias voltage for all three attenuators presented in this paper and the single-pair attenuator proposed in [7]. The attenuation is measured at the central operation frequency, which is 6 GHz for the attenuators with two-, three-, and four-pair posts, and 3 GHz for the single-pair post attenuator in [7].

TABLE III – GRAPHENE RESISTANCE VERSUS VOLTAGE FOR THE FOUR-PAIR POSTS ATTENUATOR

$V_{\text{bias}}$ (V)	$I_{\text{dc}}$ (A)	$R$ ( $\Omega$ )
0	—	1347*
3	0.0057	526
4	0.0149	267
5	0.063	79
7	0.189	37

\* Measured by using a multimeter.

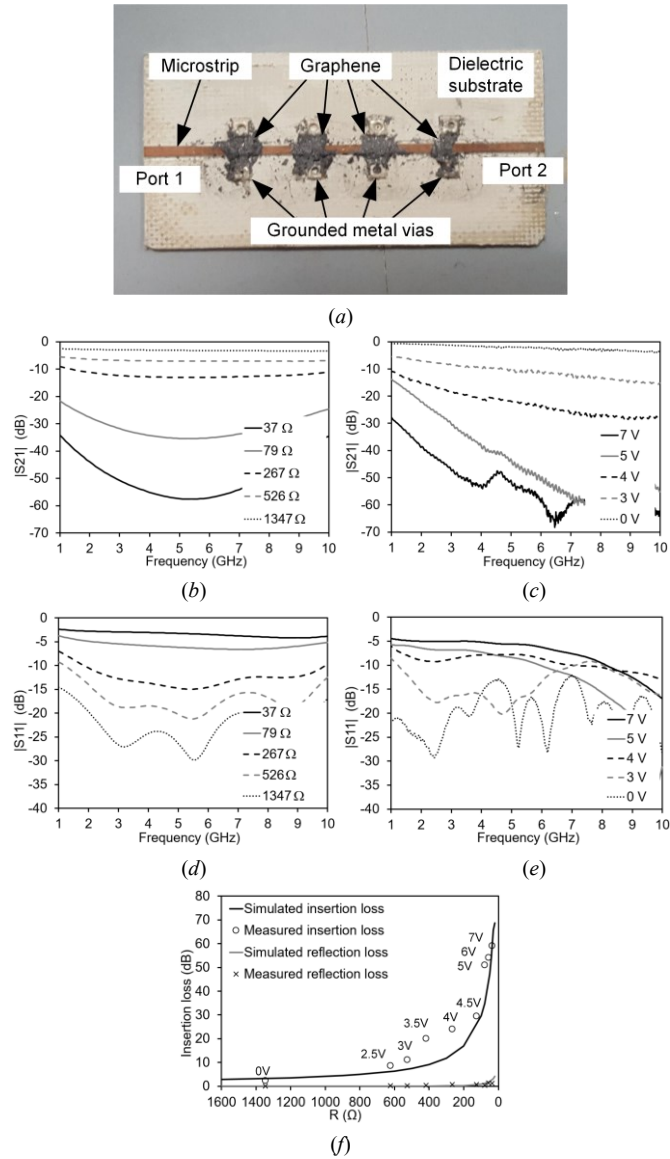


Fig. 11. Experimental verification of the four-pair posts graphene attenuator: (a) Photograph of the prototype; (b) Simulated transmission; (c) Measured transmission; (d) Simulated reflection; (e) Measured reflection; (f) Simulated and measured insertion loss at 6 GHz.

When using one single pair of graphene pads, the maximum achievable insertion loss is 15 dB, out of which 4 dB are attributed to reflection loss. Increasing the number of pairs to two results in a maximum insertion loss of 23 dB, and only 1.2 dB reflection loss. Using an even larger number of pairs allows extending the maximum insertion loss (up to more than 58 dB with four-pair posts), while keeping the reflection loss below 1.3 dB.

In the proposed solutions, the insertion loss is mainly due to dissipation, and the reflection is a very small portion of the total attenuation. Nevertheless, a reflection loss of 1.3 dB corresponds to an input matching of approximately 6 dB, which may be not enough for some applications. Of course, a better input matching can be achieved by limiting the bias voltage to lower values, with the effect to cap the maximum insertion loss.

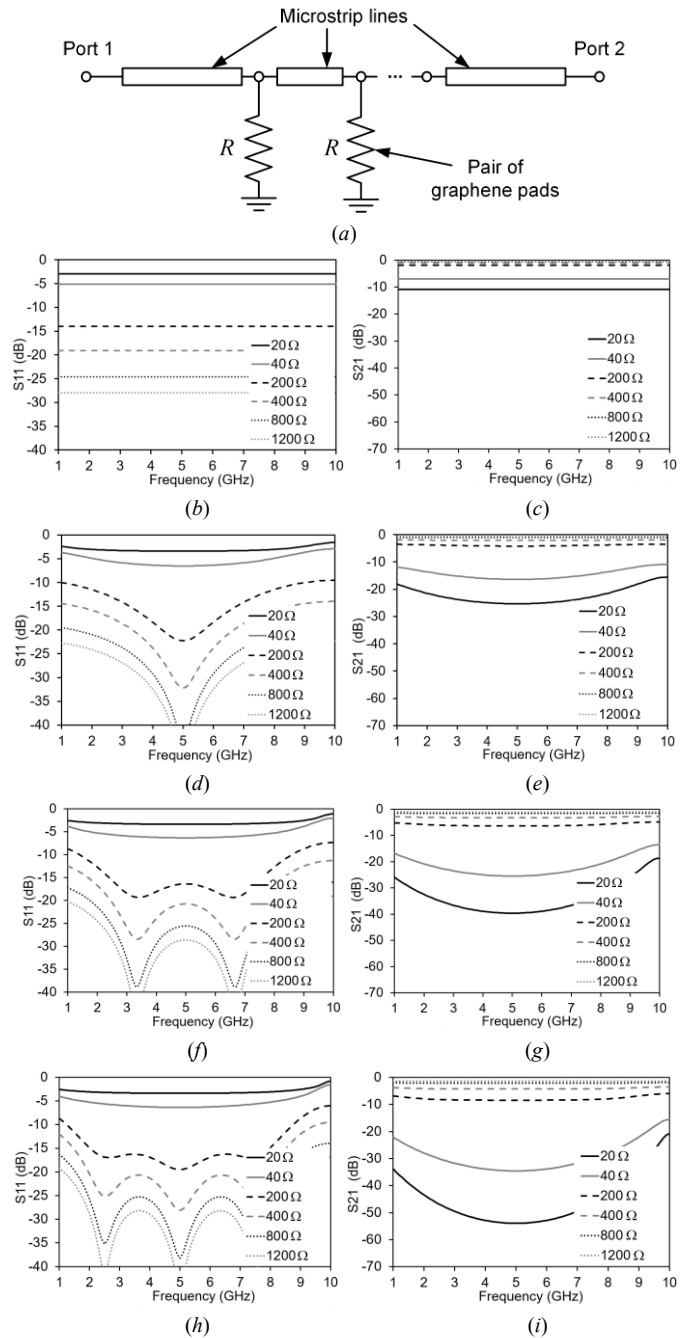


Fig. 12. Analysis of the graphene-based attenuator with different number of pairs of graphene pads, based on the equivalent circuit model: (a) Topology of the equivalent circuit model; (b) Simulated  $|S_{11}|$  for one pair of graphene pads; (c) Simulated  $|S_{21}|$  for one pair of graphene pads; (d) Simulated  $|S_{11}|$  for two pairs of graphene pads; (e) Simulated  $|S_{21}|$  for one pair of graphene pads; (f) Simulated  $|S_{11}|$  for three pairs of graphene pads; (g) Simulated  $|S_{21}|$  for one pair of graphene pads; (h) Simulated  $|S_{11}|$  for four pairs of graphene pads; (i) Simulated  $|S_{21}|$  for one pair of graphene pads.

However, in the case of the three-pair posts attenuator, the reflection loss is below 0.5 dB over the frequency band from 3 GHz to 10 GHz, which corresponds to an input matching of 10 dB. In this frequency range, this attenuator is able to reach an insertion loss larger than 30 dB.



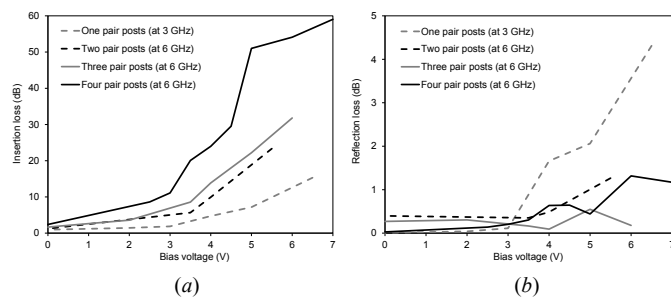


Fig. 13. Comparison of the graphene-based attenuators with different number of pairs of graphene pads: (a) Total insertion loss vs. the bias voltage at the center frequency; (b) Reflection loss vs. the bias voltage at the center frequency.

In order to locate the proposed solutions in the framework of the current state-of-the-art attenuators based on graphene technology, several recent papers on graphene attenuators are considered [26]–[28]. Table IV summarizes the key performance of the structures presented in the literature and of the three attenuators based on graphene proposed in this work. Compared with the state-of-the-art, the proposed attenuator exhibits a much larger value of maximum insertion loss, a slightly better value of minimum insertion loss, and a more limited input matching. The relative frequency band is comparable with the best cases proposed in the literature.

## VII. CONCLUSION

This paper has presented a set of voltage-controlled microstrip attenuators based on graphene technology. The cost-effective technology of few-layer graphene has been adopted for the fabrication of the attenuators. The proposed topology, based on multiple pairs of graphene pads located between the microstrip and grounded vias exhibits significant potential to achieve large values of insertion loss, while minimizing the reflection loss. Prototypes operating in the frequency band from 1 GHz to 10 GHz have been shown, outperforming the state-of-the-art in graphene attenuators in terms of maximum and minimum insertion loss. The limited accuracy in the deposition of graphene could slightly modify the electrical performance of the circuit. Nonetheless, the current accuracy is sufficient to show the physical effect and applicability at tunable microwave devices and to demonstrate the proper operation of the proposed device.

TABLE IV – COMPARISON OF GRAPHENE-BASED ATTENUATORS

	Min insertion loss (dB)	Max insertion loss (dB)	Max $ S_{11} $ (dB)	Frequency band (GHz)	Bias Voltage (V)
[26]	4	16	-15	7-15	0-4
[27]	3	15	-20	7.7-19	0-4
[28]	3	15	-15	9-40	0-4
1-pair	0.3	14	-2	0-5	0-6.5
2-pairs	1.2	20	-4	3-10	0-5.5
3 pairs	2.6	30	-10	3-10	0-6
4-pairs	3.9	48	-5	3-10	0-7

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